

OTPE JCIBI
APR 01 2003
TRADEMARK RESERVE

Date of Deposit

**Name of Applicant, Assignee or
Registered Representative**

Signature

RECEIVED
APR 08 2003
GROUP 1700

In re Application of:

Thinghao F. Wang

Serial No. 10/071,809

Filing Date: February 7, 2002

For METHOD FOR SELECTIVELY
ETCHING SILICON AND/OR
METAL SILICIDE

Examiner: Deo, Duy Vu

Group Art Unit No.: 1765

Dear Sir:

Please charge the \$930.00 filing fee to American Express Account No. 3785-716974-01002. A Credit Card Payment Form is attached. A duplicate copy of this Petition is attached.

Respectfully submitted,

SONNENSCHN NATH & ROSENTHAL
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CHICAGO, IL 60606
(312) 876-8000